

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of: SINGH et al.

Appln No.: 10/082,010

Examiner: Umez Eronini, Lynette T.

Date Filed: February 22, 2002

Group: 1765

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING  
OF METAL STRUCTURES INCLUDING REFRACTORY METAL  
BASED BARRIER LAYERS

REPLY TO NON-FINAL OFFICE ACTION

**Mail Stop Amendment**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Sir:

This Reply is responsive to the Non-Final Office Action mailed September 28, 2006.

**Amendments to the Claims** are contained in the complete claim listing which appears on pages 2-7 of this document.

**Remarks/arguments** begin on page 8 of this document.